

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**
(Not for submission under 37 CFR 1.99)

Application Number	10707918
Filing Date	2004-01-23
First Named Inventor	Siegel, Scott H.
Art Unit	2624
Examiner Name	Chu, Randolph I
Attorney Docket Number	CT 0123

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Electronic Version v18

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Title of Invention

Radiography Image Management System

Application Number :

Confirmation Number:

First Named Applicant: Scott Siegel

Attorney Docket Number: CT 0123

Art Unit:

Examiner:

Search string: (6633674 or 6178225 or 20020082850).pn

US Patent Documents

Note: Applicant is not required to submit a paper copy of cited US Patent Documents

init	Cite.No.	Patent No.	Date	Patentee	Kind	Class	Subclass
/S.K./	1	6633674	2003-10-14	Barnes et al	B1	382	232
/S.K./	2	6178225	2001-01-23	Zur et al	B1	378	98.2

US Published Applications

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/S.K./	1	20020082850	2002-06-27	Panelli	A1	705	1

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/S.K./	1	5542003	A1	1996-07-30	Wofford	Col 1, lines 9-32; col 1, lines 65 to col 2, line 22; col 2, line 56 to col 3, line 26; col 4, line 53 to col 8, line 21; col 8, line 46 to col 10, line 35; col 14, line 45 to col 16, line 40.	
/S.K./	2	6711297	B1	2004-03-23	Chang et al	Col 1, line 34 to col 2, line 27; col 2, lines 57-67; col 3, lines 1-9; col 3, line 62 to col 4, line 31; col 5, line 1 to col 6, line 16; col 13, line 55 to col 14, line 48.	
/S.K./	3	6633684	B1	2003-10-14	James	Background document	
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